



FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE  
(Modified) PATENT AND TRADEMARK OFFICE

ATTY. DOCKET NO.  
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APPL.N. NO.  
09/989,898

INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT

(Use several sheets if necessary)

APPLICANT:  
Laurence M. C. Lai et al.

FILING DATE  
19 November 2001

GROUP  
1765

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
AKA	6,355,387	03/2002	Fujinaga et al.	430	30	

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT NUMBER	PUBLISHED DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

AKA	Stanley Wolf and Richard N. Tauber, "Silicon Processing for the VLSI Era", Vol. 1, pp. 520-524, (1986).
↓	G. Daniel Woodring and Rufus R. C. Benton, "Chemical Blanking", Tool and Mfg. Engr., Vol. 52, pp. 87-90, (May 1964).
↓	"Chemical Milling for Thin Complex Parts", Metal Industry, Vol. 103, p. 188, (August 1963).

EXAMINER

Shrita K. Shankar

DATE CONSIDERED

3/22/04

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.